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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Masaki HIRASE et al.

Serial Number: NEW

Filed: July 20, 2001

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

11000 U.S. PRO
09/908941
07/20/01

INFORMATION DISCLOSURE STATEMENT

Director of Patents and Trademarks
Washington, D.C. 20231

July 20, 2001

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN, HATTORI
McLELAND & NAUGHTON



Donald W. Hanson
Reg. No. 27,133

Atty. Docket No.: 010917
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
Tel: (202) 659-2930
Fax: (202) 887-0357
DWH/lif
Enclosures: PTO-1449; Reference (1).